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# Compositional tuning of yttrium iron garnet film properties by multi-beam pulsed laser deposition



Alberto Sposito<sup>a,\*</sup>, Gavin B.G. Stenning<sup>b</sup>, Simon A. Gregory<sup>b</sup>, Peter A.J. de Groot<sup>b</sup>, Robert W. Eason<sup>a</sup>

<sup>a</sup> Optoelectronics Research Centre, University of Southampton, Southampton SO171BJ, United Kingdom

<sup>b</sup> Physics and Astronomy, University of Southampton, Southampton SO171BJ, United Kingdom

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#### ABSTRACT

We report an investigation of the effects of variation of composition on the properties of yttrium iron garnet films grown on yttrium aluminium garnet substrates by multi-beam pulsed laser deposition. The ferromagnetic resonance linewidth is used as a quality factor: a significant variation is noticed from changing composition, with an experimentally observed optimum at  $Y_{3.5}Fe_{4.5}O_{12}$ .

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#### 1. Introduction

Yttrium iron garnet ( $Y_3Fe_5O_{12}$ ), often abbreviated as YIG, is a cubic crystal featuring ferromagnetic and magneto-optic properties, which can be used in different application fields, ranging from optical communications, where Faraday and Kerr effects in YIG can be exploited for optical isolators and rotators [1], to microwave, where phase shifters, circulators and filters can be made thanks to the magnetic properties and the narrow ferromagnetic resonance (FMR) linewidth of YIG at GHz frequencies [2].

YIG and magneto-optic garnet films can be grown by several deposition techniques, such as liquid phase epitaxy (LPE) [3], sputtering [4] and pulsed laser deposition (PLD). Although LPE allows the growth of very high-quality YIG layers, PLD has proven to be a relatively cheap, fast and versatile deposition method for several crystals, including garnets [5]; moreover it is possible to grow thermodynamically unstable materials, such as Bi:YIG and BIG (Bismuth Iron Garnet,  $Bi_3Fe_5O_{12}$ ), which cannot be grown by LPE [6].

PLD-grown YIG films on GGG (Gadolinium Gallium Garnet,  $Gd_3Ga_5O_{12}$ ) substrates with an FMR linewidth comparable to that of LPE-deposited YIG films on GGG [7] have recently been reported in [8]. More recently we have reported optimised PLD of YIG on YAG (Y<sub>3</sub>Al<sub>5</sub>O<sub>12</sub>) substrates, which are cheaper than GGG and seem to induce better magnetic properties in the overgrown YIG layers [9]. However, single-beam PLD from a stoichiometric target usually leads to films

that are iron (Fe) deficient, as previously reported in the literature [8] and confirmed in our experiments [9]. For this reason we have studied the composition and the effects of stoichiometric variation on the resultant properties of PLD-grown YIG films, whose yttrium (Y) and Fe concentration is varied by co-ablation of two separate targets of polycrystalline YIG with either an yttria ( $Y_2O_3$ ) or an iron oxide (Fe<sub>2</sub>O<sub>3</sub>) target.

#### 2. Experimental techniques

#### 2.1. Fabrication

All YIG films were grown on  $10 \times 10 \text{ mm}^2 \times 1 \text{ mm-thick}$  (100)-oriented YAG substrates in our multi-beam, multi-target ('multi-PLD' from now on) deposition chamber, described in detail in [10]. Up to three targets can be ablated with a KrF excimer laser, a Coherent COMPexPro 102F operating at  $\lambda = 248$  nm (20 ns pulse duration), and two frequency-quadrupled Nd:YAG lasers, Continuum Surelite II-10 operating at  $\lambda = 266$  nm (~5 ns pulse duration) with a fixed pulse repetition rate of 10 Hz. A Synrad J48-2W carbon dioxide (CO<sub>2</sub>) laser operating at 10.6 µm (max. output power: 40 W) was used to heat the substrate during the deposition: the laser beam was raster-scanned on the back-side of the substrate, as described in [10]. The substrates were continuously rotated during the depositions to improve thickness uniformity. The targets were rotated and tilted continuously, in order to improve film homogeneity and ensure a uniform usage of the target surface. The targets used were a polycrystalline YIG target and sintered Y<sub>2</sub>O<sub>3</sub> and Fe<sub>2</sub>O<sub>3</sub> targets. The vacuum chamber was pumped down to a base



<sup>\*</sup> Corresponding author. *E-mail address:* as11g10@orc.soton.ac.uk (A. Sposito).

#### Table 1

Summary table of targets and lasers used, as described in each section of this paper.

Section\targets	YIG	Fe <sub>2</sub> O <sub>3</sub>	Y <sub>2</sub> O <sub>3</sub>
3.1.1	KrF	-	-
3.1.2	Nd:YAG	-	-
3.2.1	Nd:YAG	KrF	-
3.2.2	KrF	Nd:YAG	-
3.3	Nd:YAG	-	KrF

pressure at least two orders of magnitude lower than the deposition value (i.e.  $P_{\text{base}} < 0.068$  Pa), then filled with O<sub>2</sub>.

The substrate temperature was set to the maximum value possible with this system, i.e.  $T \approx 1150$  K, which is ~100 K lower than the optimum value we found for YIG growth on YAG (~1250 K) in our single-beam single-target PLD system. The duration of each deposition was set at ~72,000 laser pulses, unless otherwise stated.

Before starting the multi-PLD experiments, preliminary YIG depositions were performed in the multi-PLD chamber, in order to fine-tune the growth conditions of pure YIG and compare ablation of the YIG target with the KrF laser and the frequency-quadrupled Nd:YAG laser, as described in Section 3.1. Multi-PLD experiments of YIG and Fe<sub>2</sub>O<sub>3</sub>, performed to study the effect of Fe-deficiency compensation, are described in Section 3.2, and the results of multi-PLD of YIG and Y<sub>2</sub>O<sub>3</sub> are discussed in Section 3.3. An important experimental point to note is that the Y<sub>2</sub>O<sub>3</sub> target cannot be ablated with the Nd:YAG laser and for this reason the experiments with it were performed only with the laser set-up described below in Table 1.

#### 2.2. Characterisation

The thickness of the YIG films was measured by a stylus profiler (KLA-Tencor P-16). Surface morphology was determined by optical microscopy and scanning electron microscope (Zeiss Evo 50), normally operated in variable pressure mode, with a 100 µm aperture, a voltage of 20 kV and a probe current of 2 nA. The composition was checked by energy-dispersive X-ray spectroscopy or EDX (Oxford Instruments INCA PentaFETx3), with a cobalt stub used for energy calibration before measurements and the stoichiometric YIG target and blank YAG substrates used for reference; oxygen concentration was assumed constant at 12 formula units (i.e. 60 at.%) and the accuracy of the concentration of the other elements was estimated as ~0.04 formula units. Crystallographic analysis was performed by X-ray diffraction or XRD (Bruker D2 Phaser, with a  $\theta$ - $\theta$  configuration and a copper (Cu) X-ray source emitting at  $K_{\alpha 1}$  and  $K_{\alpha 2}$  wavelengths), with a resolution  $\Delta 2\theta = 0.01^{\circ}$ . Transmission spectra were taken with the Varian Cary 500 Scan spectrophotometer. The broadband FMR spectroscopy was performed as described in [9,11], using a vector network analyser (HP E5071C) FMR technique (VNA-FMR), which allows FMR in the frequency range of 300 kHz to 20 GHz: the FMR linewidth of YIG films was measured with an accuracy of the order of 0.1 mT. The measurements were performed at a fixed excitation frequency of 6 GHz to ensure saturation of the sample within the applied field range available. DC magnetic fields of up to 0.6 T were available. For the characterisation of each film the applied magnetic field is swept while monitoring the scattering matrix



Fig. 1. Optical transmission spectra of E1-4 and Y20. Ripples are etalon fringes [15].

parameter  $S_{21}$  (microwave absorption). This method reveals sub-mT features or 'satellites' of the main FMR mode. These modes can have several origins, such as (*i*) an increase in the intrinsic linewidth of the film by a process known as inhomogeneous broadening, as VNA-FMR excites only a very narrow frequency in time, and (*ii*) spin-waves and unresolved magnetostatic (dipolar) modes [12,13]. These arise from the geometry of the  $H_{\rm RF}$  (microwave excitation field) with respect to the applied magnetic field H [14]. Both of these would contribute to obscuring the true intrinsic linewidth measurement for the film.

#### 3. Results and discussion

#### 3.1. Comparison of YIG ablation with different lasers

In this section we compare the ablation of a polycrystalline YIG target with two different lasers: a KrF excimer laser ( $\lambda = 248 \text{ nm}$ ) and a frequency-quadrupled Nd:YAG laser ( $\lambda = 266 \text{ nm}$ ). We also discuss the optimisation of YIG growth in the multi-PLD chamber.

#### 3.1.1. Ablation of YIG with the KrF laser

First of all, a deposition test (sample E1) was performed under the same conditions as Y20, the best YIG film grown on YAG in our singlebeam single-target ("single-PLD") system [9], except for substrate temperature ( $T \approx 1150$  K), which is limited by the heating method in our multi-PLD system: KrF laser fluence was set at  $F_{\rm KrF} \approx 3 \, \text{J/cm}^2$ , pulse repetition rate at  $f_{\rm KrF} \approx 20$  Hz, oxygen pressure at  $P_{02} \approx 1$  Pa and target– substrate distance d at  $\approx$  6 cm. As shown in Table 2, there are only two big differences between Y20 and E1: film thickness and the FMR linewidth ( $\Delta H$ ). The lower film thickness in E1, compared to Y20, is due to the continuous tilting of the targets during their ablation and to the target configuration in the multi-PLD chamber, where the three target holders are symmetrically off-axis with respect to the substrate, thus causing a lower deposition rate, compared to film growth in the single-PLD system with the on-axis configuration. The FMR linewidth is almost twice the value of Y20, most likely because of the lower substrate temperature: in fact, the FMR linewidth of E1 is roughly the same as that of Y11 ( $\Delta H \approx 2.9$  mT), grown under similar conditions ( $T \approx 1150$  K, d =6 cm,  $P_{02} \approx 3.3$  Pa) [9].

Table 2

Deposition conditions and results of samples E1-E4. Sample Y20 is shown as a reference. "Conc." stands for concentration

ID	Р <sub>О2</sub> [Ра]	Target– substrate distance d [cm]	Thickness t [μm]	Y conc. [formula number]	Fe conc. [formula number]	Fe/Y	<i>∆H</i> [mT]	Sample colour	
Y20	1	6	2.4	3.55	4.45	1.25	1.8	Yellow	
E1	1	6	1.4	3.54	4.46	1.26	3.0	Yellow	
E2	1	4	3.3	3.36	4.64	1.38	7.2	Dark yellow	
E3	3.4	4	2.5	3.52	4.48	1.27	3.9	Yellow	
E4	6.8	4	2	3.47	4.53	1.31	6.6	Yellow	

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